

OFFICIAL

Applicant:	Farrell, et al.	Docket No:	TI-33431
Serial No:	10/034,788	Examiner:	Fox, Charles
Filed:	12/27/2001	Art Unit:	3652
For:	BI-DIRECTIONAL WAFER TRANSFER MECHANISM AND METHOD		

PAGE 2/2 * RCVD AT 7/16/2004 3:29:07 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-1/1 * DNLS:8729306 * CSID:972 917 4417 * DURATION (mm:ss):01:00